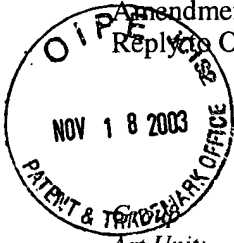


Application No. 09/633,002  
Amendment dated November 13, 2003  
Reply to Office Action dated June 17, 2003



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF MAILING

Art Unit: 1762  
Attorney  
Docket No.: NPO0005-01  
Applicant: Keiji Ishibashi  
Invention: A HOT ELEMENT CVD  
APPARATUS AND A  
METHOD FOR REMOVING  
A DEPOSITED FILM  
Serial No.: 09/633,002  
Filed: August 4, 2000  
Examiner: Wesley D. Markham

I HEREBY CERTIFY THAT THIS correspondence  
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Alexandria, VA 22313-1450 on: November 13,  
2003.

ANTHONY NIEWYK, REG. NO. 24, 871

Name of Registered Representative

Signature

November 13, 2003

Date

AMENDMENT

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Final Office Action dated June 17, 2003, which had a period for  
response which expired on September 17, 2003, which period has been extended by the enclosed  
two-month Petition For Extension Of Time to expire on November 17, 2003, Applicant hereby  
submits the following amendment:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2  
of this paper.

**Remarks** begin on page 6 of this paper.